- 39. The substrate of claim 36 wherein the antireflective composition further comprises a melamine crosslinker component.
- 40. The substrate of claim 36 wherein the antireflective composition comprises a thermal acid generator.
- 41. The substrate of claim 36 wherein the antireflective composition comprises an anthracene material.
 - 42. Thé substrate of claim 36 wherein the substrate is a microelectronic wafer.
 - 43. A coated substrate comprising:

a substrate having thereon:

a coating layer of an antireflective composition, the antireflective composition comprising a crosslinker and an anthracene material; and

a coating layer of a photoresist composition over the antireflective layer.

- 44. The substrate of claim 43 wherein the antireflective composition layer is crosslinked.
- The substrate of claim 43 wherein the antireflective composition comprises a thermal acid generator.
 - 46. The substrate of claim 43 wherein the substrate is a microelectronic wafer.

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47. A method for forming a relief image on a substrate comprising: applying on the substrate a layer of an antihalation composition comprising a benzoguanamine crosslinker;

applying over the antihalation composition layer a photoresist composition.

- 48. The method of claim 47 wherein the antihalation composition layer is crosslinked prior to applying the photoresist composition.
- 49. The method of claim 47 wherein the antireflective composition comprises a benzoguanamine resin.
- 50. The method of claim 47 wherein the antireflective composition further comprises a melamine crosslinker component.
- 51. The method of claim 47 wherein the antireflective composition comprises a thermal acid generator.
- 52. The method of claim 47 wherein the antireflective composition comprises an anthracene material.
 - 53. The method of claim 47 wherein the substrate is a microelectronic wafer.

54. A method for forming a relief image on a substrate comprising:
applying on the substrate a layer of an antihalation composition comprising an anthracene material;

applying over the antihalation composition layer a photoresist composition.